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PATENT



45681

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :
Michael K. Denk et al. :
Serial No.: 10/643,090 :
Filed: August 19, 2003 :
For: A NEW CLASS OF VOLATILE :
COMPOUNDS FOR THE DEPOSITION :
OF THIN FILMS OF METALS AND :
METAL COMPOUNDS :
:

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with 37 C.F.R. § 1.97 and § 1.98, Applicants bring the disclosures listed on completed Form PTO-1449 to the Examiner's attention and requests that they be considered and made of record in this application.

Prompt examination on the merits is respectfully requested.

Respectfully submitted,

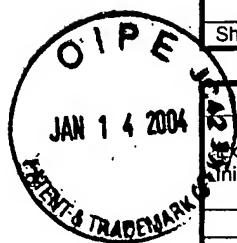

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Dated: January 14, 2004

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Substitute for form 1449A/PTO				Complete if Known	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(use as many sheets as necessary)</i>				Application Number	10/643,090
				Filing Date	August 19, 2003
				First Named Inventor	Michael K. Denk
				Art Unit	
				Examiner Name	
Sheet	1	of	1	Attorney Docket Number	45681



NON PATENT LITERATURE DOCUMENTS			
Examiner Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publishers, city and/or country where published	

Examiner Signature		Date Considered	
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